



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

August 30, 2025

IGI Report Number **LG731558273**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **ROUND BRILLIANT**

Measurements **12.85 - 12.90 X 7.81 MM**

GRADING RESULTS

Carat Weight **8.03 CARATS**

Color Grade **E**

Clarity Grade **VS 1**

Cut Grade **IDEAL**

ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG731558273**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.

Type Ila

LG731558273
Report verification at igi.org

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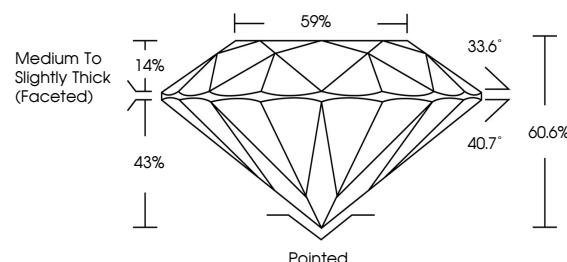
E

Color Grade **VS 1**

IDEAL

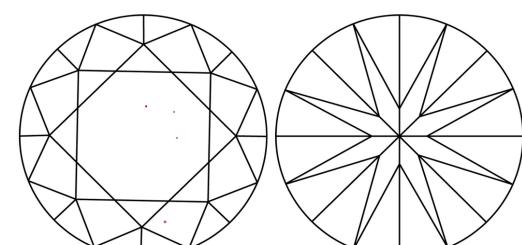
Clarity Grade **IDEAL**

PROPORTIONS



Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light
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CLARITY

IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
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Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included
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Symmetry **NONE**

NONE

Fluorescence **None**

None

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[www.igi.org](https://igi.org)

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